

Docket No.: 50195-257



PATENT

#7  
ECT (1A1) f  
SDams  
3/6/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Norihiko KIRITANI

Serial No.: 09/817,154 ✓

Group Art Unit: 2823

Filed: March 27, 2001

Examiner: F. Toledo

For: METHOD FOR MANUFACTURING SILICON CARBIDE DEVICE AND OXIDATION FURNACE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
Washington, DC 20231

Sir:

It is respectfully requested that the time for response to the Office Action dated October 24, 2002, now due to expire January 24, 2003, be extended for one month(s) and set to expire on February 24, 2003.

Please charge the extension fee of \$110.00 to Deposit Account No. 500417 . Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

A handwritten signature in cursive script, reading "Cameron K. Weiffenbach".

Cameron K. Weiffenbach  
Registration No. 44,488

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202) 756-8000 CKW:jdj  
Facsimile: (202) 756-8087  
**Date: February 24, 2003**